



P/4178-9

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Masanobu SATO et al.

Date : January 18, 2005

Serial No. : 10/669,520

Group Art Unit : 1734

Filed : September 24, 2003

Examiner : Yewebdar T. Tadesse

Confirmation No. : 4349

For : SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE
PROCESSING SYSTEM

**Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**

RESPONSE

Sir:

This is a response to the Office Action mailed December 15, 2004 in the above-identified application.

The applicants elect Invention I, claims 1-11, without traverse.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on January 18, 2005:

James A. Finder

Name of applicant, assignee or
Registered Representative

Signature

January 18, 2005

Date of Signature

Respectfully submitted,

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